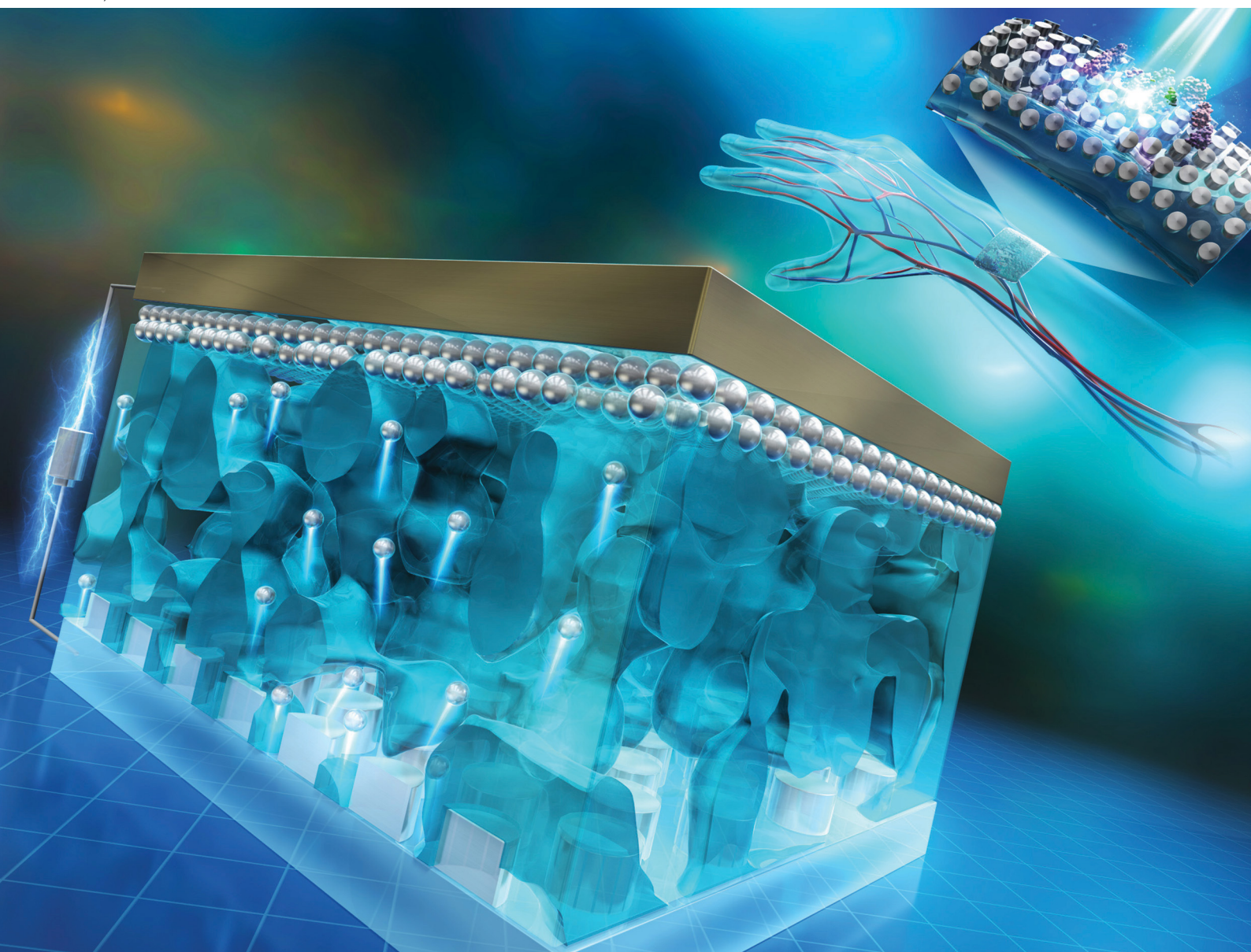


Materials Advances

Volume 6
Number 16
21 August 2025
Pages 5327–5794

rsc.li/materials-advances



ISSN 2633-5409

PAPER

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Maskless soft lithography for fabricating micro- and nano-scale Ag structures *via* solid-state electrochemical etching using a polymer electrolyte membrane for optoelectronic and sensing applications